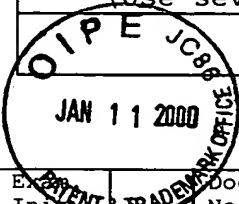


		Atty. Docket No. 1375P1	Serial No. 09/334,193
<b>LIST OF CITATIONS BY APPLICANT</b> (Use several sheets if necessary)		Applicant: Dennis J. O'Shaughnessy	
		Filing Date June 16, 1999	Group 1753

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Ex- Initial	Document No.	Date	Name	Class	Subclass	Filing Date if appropriate
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AD						
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AH						
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AJ						
AK						

**FOREIGN PATENT DOCUMENTS**

	Document No.	Date	Country	Class	Subclass	Translation Yes No
AL						
AM						
AN						
AO						
AP						
AQ						

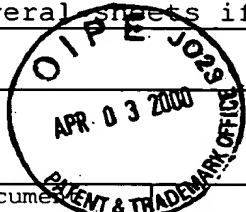
**OTHER CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)**

AR	
AS	
AT	

Examiner <i>[Signature]</i>	Date Considered <i>12/00</i>
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Exam. Init.		Document No.	Date	Name	Class	Subclass	Filing Date if appropriate
<i>[initials]</i>	AA	4,610,771	9/86	Gillery	204	192.1	
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	AH						
	AI						
	AJ						
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		Document No.	Date	Country	Class	Subclass	Translation Yes No	
<i>[initials]</i>	AL	0 698 585	2/96	EPO				
	AM	08-171824	7/96	Japan (abstract)				X
	AN	0 751 099	1/97	EPO				
	AO	2 311 540	10/97	Great Britain				
	AP	0 803 481	10/97	EPO				
	AQ	2 315 496	2/98	Great Britain				

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<i>[initials]</i>	AR	Qiu, C. X. et al., "Tin- and indium-doped zinc oxide films prepared by RF magnetron sputtering", <b>SOLAR ENERGY MATERIALS, FEB.-MARCH 1986, NETHERLANDS</b> , vol. 13, no. 2, pp. 75-84
	AS	
	AT	

Examiner <i>[signature]</i>	Date Considered <i>12/00</i>
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